Supplementary information for:

Fabrication and enhanced photoelectric properties of novel Bi₉O_{7.5}S₆/CdS composite film

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Fig. S1 Schematic illustration of the preparation of $Bi_9O_{7.5}S_6/CdS/ITO$ composite film.



Fig. S2 Cross-sectional SEM images and EDS results of CdS/ITO (a, b), $Bi_9O_{7.5}S_6/ITO$ (c, d) and $Bi_9O_{7.5}S_6/CdS/ITO$ (e, f) films. SEM (g) and EDS mapping (h-l) images of $Bi_9O_{7.5}S_6/CdS$ heterostructure at the cross-section.



Fig. S3 XPS spectra of $Bi_9O_{7.5}S_6$, CdS and $Bi_9O_{7.5}S_6/CdS$: (a) Bi 4f, (b) Cd 3d, (c) O 1s and (d) S 2s spectra.



Fig. S4 Response times of CdS/ITO (a) and Bi₉O_{7.5}S₆/ITO (b) films at 1 V bias voltage.



Fig. S5 Cross-sectional SEM images of Bi₉O_{7.5}S₆/ITO films with different thicknesses.



Fig. S6 Cross-sectional SEM images of $Bi_9O_{7.5}S_6/CdS/ITO$ films with different thicknesses.



Fig. S7 Cross-sectional SEM images of CdS/ITO films with different thicknesses.



Fig. S8 The XRD pattern of $Bi_9O_{7.5}S_6/CdS/ITO$ composite film after keeping in air and glove box respectively for 2 weeks.